

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

PATENT

Applicant: Jugo Mitomo

Serial No.: not yet assigned

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For: SEMICONDUCTOR LASER AND
METHOD OF PRODUCTION THEREOF

Case No.: 9792909-5153

Group Art Unit: not yet assigned

Examiner: not yet assigned

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PRELIMINARY AMENDMENT ACCOMPANYING APPLICATION

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Dear Sir:

Between the title and the heading "Background of Invention" on page 1, insert the following:

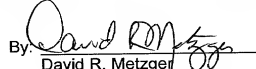
--RELATED APPLICATION DATA

The present invention claims priority to Japanese Application No. P2000-258139, filed August 23, 2000, which application is incorporated herein by reference to the extent permitted by law.--

Respectfully submitted,

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